

POLYMER SOLUTIONS

# EOS P 770

- Thanks to optimized temperature management, improved recoating speed and high-power lasers, the build time and cost-per-part are reduced significantly.
- The improved digital scanners achieve a considerably higher laser accuracy compared to the previous version of the system. As a result the overlap area has no visible edges.
- The well-established EOSAME feature homogenizes the energy input, thus ensuring excellent mechanical part properties and dimensional accuracy within the overall build volume\*.
- The spot pyrometer enables continuous and accurate temperature control.
- With 10 commercial polymer materials and 18 combinations of materials/layer thicknesses currently available, EOS is a benchmark in terms of material variety. In addition, the EOS ParameterEditor allows customized exposure parameters to be defined based on proven starting values.
- After production, the CoolDown Station provides optimal conditions to cool down the exchangeable frame. This leads to the best properties in the final part – in particular with regard to dimensional accuracy and color stability.

\* the specified build volume depends on the material; for PA 2200 it is 700 x 380 x 580 mm (27.6 x 15 x 22.9 in)



EOS P 770

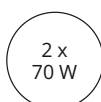
## Additive Manufacturing of Series Parts Up to 1 Meter in Length

Laser Sintering System with Two Lasers for the Production of Large Parts and for Industrial High-Throughput Manufacturing

With the largest build volume available on the market, the EOS system enables the production of parts of up to one meter in length. Thanks to its new hardware and software features, the EOS P 770 is up to 20% more productive than its predecessor.

### EXPOSURE MODULE

LASERS



# SOFTWARE



## EOS SYSTEM SUITE

EOS System Suite optimizes production by streamlining processes, integrating with MES and shop-floor IT systems, and generating detailed quality reports.



## TECHNICAL DATA

<b>BUILD VOLUME</b>	700 x 380 x 580 mm (27.6 x 15.0 x 22.8 in)
<b>LASER TYPE</b>	CO <sub>2</sub> ; 2 x 70 W
<b>PRECISION OPTICS</b>	2 F-theta-lens(es); 2 High-speed scanner(s)
<b>SCAN SPEED</b>	up to 10.0 m/s (32.8 ft/s)
<b>POWER SUPPLY</b>	1 x 32 A
<b>POWER CONSUMPTION</b>	max. 12.0 kW / typical 3.1 kW

## MATERIALS & PROCESSES

EOS has exceptional materials expertise and a comprehensive portfolio of highly developed materials for additive manufacturing. Our materials, systems and process parameters fit together optimally. With the right materials, you can realize the desired property profiles in the best possible way for your products

## EOS P 770

PA 1100



PA 1101



PA 1101 ClimateNeutral



PA 1102 Black



PA 2200 Balance



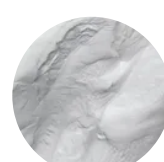
PA 2200 CarbonReduced Balance



PA 2200 Performance



PA 2200 CarbonReduced Performance



PA 2200 Speed



PA 2200 CarbonReduced Speed



PA 2200 Top Quality



PA 2200 CarbonReduced Top Quality



PA 2200 Top Speed



PA 2200 CarbonReduced Top Speed



PA 2201



PA 3200 GF



Alumide



EOS TPU 1301



PA 2210 FR



PA 2241 FR



## OPTIONAL ACCESSORIES

### IPCM P Plus

Fully Automatic With a Closed Powder Cycle

### Unpacking & Sieving Station

Unpacking and sieving station quickly removes excess material from the components, sieve and conveys used powder

### Blasting Cabinet

Manually or automatically depowder components using glass or plastic blasting media

### Cool Down Cover

### IPCM P

Semi-Automated and Versatile

## HEADQUARTERS

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Status as of 31.03.2025. Subject to technical modifications. EOS is certified according to ISO 9001.

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